

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
)  
Shinji MAEKAWA et al. )  
)  
Serial No.: 10/827,457 )  
)  
Filed: April 19, 2004 )  
)  
For: Method For Forming Pattern And )  
Drop Discharge Apparatus )  
)  
Examiner: Marianne L. Padgett )  
)  
Art Unit: 1715 )  
)  
Confirmation No.: 2984 )

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT J (AFTER FINAL)**

Applicants have the following response to the Final Rejection of June 23, 2009.

Please amend the above-identified application as follows: